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Docket No.: 57810-032

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: Customer Number: 20277

Masayuki HATA, et al.

: Confirmation Number: 2755

Application No.: 10/081,180

: Group Art Unit: 1765

Filed: February 25, 2002

: Examiner: Robert M. Kunemund

For: NITRIDE-BASED SEMICONDUCTOR ELEMENT AND METHOD OF FORMING
NITRIDE-BASED SEMICONDUCTOR

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated May 20, 2004.